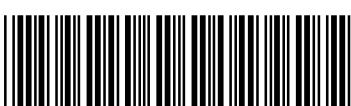


Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10500210	YAMASHITA ET AL.
	Examiner	Art Unit
	WEN-YING P CHEN	2871

SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES

Search Notes	Date	Examiner
reviewed previously cited references	7/16/2008	wpc
consulted primary examiner Andrew Schechter regarding the submitted affidavit	7/16/2008	wpc

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner